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APPLICATION NO.	FILING DATE	FIRST NAMED INVENTOR	ATTORNEY DOCKET NO.	CONFIRMATION NO.
10/792,297	03/04/2004	Fumiko Shiraishi	Q80180	3153
23373	7590	04/14/2008	EXAMINER	
SUGHRUE MION, PLLC 2100 PENNSYLVANIA AVENUE, N.W. SUITE 800 WASHINGTON, DC 20037			SHEEHAN, JOHN P	
		ART UNIT	PAPER NUMBER	
		1793		
		MAIL DATE	DELIVERY MODE	
		04/14/2008	PAPER	

Please find below and/or attached an Office communication concerning this application or proceeding.

The time period for reply, if any, is set in the attached communication.



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4-14-08

In re application of
Fumiko Shiraishi, et al.
Serial No. 10/792,297
Filed: March 4, 2004
For: Method Of Manufacturing Magnetic Particle, Magnetic
Particle And Magnetic Recording Medium

DECISION ON
PETITION

This is a decision on the petition filed on February 11, 2008. The petition requests to reset the period for Reply from the office action mailed on November 23, 2007. Applicants assert that the actual date of receipt of the Office Action was February 8, 2008.

DECISION

The instant request is accepted as a timely petition under 37 C.F.R. 1.181 (no fee), and is evaluated under the procedures regarding an acceptable showing of non-receipt of an office action, TMOG 1156 O.G. 53, November 16, 1993, (see also MPEP 711.03(c) - NEW PROCEDURE TMOG 1170 O.G. 114). A review of the petitioner's evidence indicates that the request has merit. The evidence presented is sufficient to establish that the applicant or any authorized representative of the applicant did not receive the office action mailed on November 23, 2007 until February 8, 2008.

The period for response will be set from a date of February 7, 2008

The Petition is **GRANTED**.

Jacqueline M. Stone

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